



Docket No.: 53074-025

17/3
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

UEDA, Tetsuzo

Serial No.: 09/904,129

Group Art Unit:

Filed: July 11, 2001

Examiner:

For: BUFFER LAYER AND GROWTH METHOD FOR SUBSEQUENT EPITAXIAL
GROWTH OF III-V NITRIDE SEMICONDUCTORS

CORRESPONDENCE ADDRESS CHANGE

Commissioner for Patents and Trademarks
Washington, D. C. 20231

Sir:

Please change the records to indicate the current firm name and telephone number for the
above-identified application and forward all future correspondence as follows:

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Respectfully submitted,

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